

RECEIVED SEP 0 4 2003 TC 1700

Serial No. 10/046,282 SEC.863

Amendment dated August 28, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent application of

Chul-Hwan Choi et al.

Group Art Unit 2826

Serial No. 10/046,282

Examiner Johannes P. Mondt

Filed January 16, 2002

RESIDUAL GAS REMOVING DEVICE AND METHOD THEREOF

AMENDMENT

U.S. Patent and Trademark Office 2011 South Clark Place Customer Window, **Mail Stop Non-Fee Amendment** Crystal Plaza Two, Lobby, Room 1B03 Arlington, VA 22202

Sir:

In response to the Office action of June 2, 2003, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.